

Day : Sunday

Date: 3/21/2004

Time: 14:59:57

## PALM INTRANET

## Inventor Name Search Result

Your Search was:

Last Name = SAITOH

First Name = HIDETOSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 8
<u>10614290</u>	Not Issued	030	07/08/2003	PROCESS FOR PRODUCING THIN METAL OXIDE FILM	SAITOH, HIDETOSHI
<u>10433090</u> <i>20040036059</i>	Not Issued	030	05/30/2003	PROCESS FOR PRODUCING FLUORESCENT METAL OXIDE MATERIAL	SAITOH, HIDETOSHI <i>IFW</i>
<u>09776857</u>	<u>6465042</u>	150	02/06/2001	MATERIAL HAVING TITANIUM DIOXIDE CRYSTALLINE ORIENTATION FILM AND METHOD FOR PRODUCING THE SAME	SAITOH, HIDETOSHI
<u>09673920</u>	6589453	150	12/13/2000	A PROCESS PREPARING A TARGET FOR A THIN METAL OXIDE FILM	SAITOH, HIDETOSHI
<u>09035906</u>	<u>6228502</u>	150	03/06/1998	MATERIAL HAVING TITANIUM DIOXIDE CRYSTALLINE ORIENTATION FILM AND METHOD FOR PREPARING THE SAME	SAITOH, HIDETOSHI
<u>07353408</u>	<u>4887955</u>	150	05/17/1989	<u>UNIT INJECTOR</u>	SAITOH, HIDETOSHI
<u>07059058</u>	Not Issued	161 <i>abd</i>	06/08/1987	UNIT INJECTOR	SAITOH, HIDETOSHI
<u>06566386</u>	Not Issued	161 <i>al</i>	12/28/1983	INJECTION TIMING CONTROL SYSTEM FOR FUEL INJECTION PUMP	SAITOH, HIDETOSHI

Inventor Search Completed: No Records to Display.

Search Another: Inventor

Last Name	First Name	
<input type="text" value="saitoh"/>	<input type="text" value="hidetoshi"/>	<input type="button" value="Search"/>

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Day : Sunday  
Date: 3/21/2004

 **PALM INTRANET**

Time: 15:02:25

**Inventor Name Search Result**

Your Search was:

Last Name = OHSHIO

First Name = SHIGEO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<i>shigeo</i> <u>10614290</u>	Not Issued	030	07/08/2003	PROCESS FOR PRODUCING THIN METAL OXIDE FILM	OHSHIO, SHIGEO
<i>w/HS</i> <u>09776857</u>	<u>6465042</u>	150	02/06/2001	MATERIAL HAVING TITANIUM DIOXIDE CRYSTALLINE ORIENTATION FILM AND METHOD FOR PRODUCING THE SAME	OHSHIO, SHIGEO
<i>parent</i> <u>09673920</u>	<u>6589453</u>	150	12/13/2000	A PROCESS PREPARING A TARGET FOR A THIN METAL OXIDE FILM	OHSHIO, SHIGEO
<i>w/HS</i> <u>09035906</u>	<u>6228502</u>	150	03/06/1998	MATERIAL HAVING TITANIUM DIOXIDE CRYSTALLINE ORIENTATION FILM AND METHOD FOR PREPARING THE SAME	OHSHIO , SHIGEO

**Inventor Search Completed: No Records to Display.**

**Search Another: Inventor**

<b>Last Name</b>	<b>First Name</b>	
<input type="text" value="ohshio"/>	<input type="text" value="shigeo"/>	<input type="button" value="Search"/>

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Day : Sunday  
Date : 3/21/2004

## PALM INTRANET

Time: 15:03:23

## Inventor Name Search Result

Your Search was:

Last Name = SATOH

First Name = RYO

*This case*

Application#	Patent#	Status	Date Filed	Title	Inventor Name 50
<del>29145702</del>	<del>D471T80</del>	150	07/27/2001	KARAOKE CONTROLLER WITH MICROPHONE	<del>SATOH, RYOICHI</del>
<del>10614290</del>	Not Issued	030	07/08/2003	PROCESS FOR PRODUCING THIN METAL OXIDE FILM	SATOH, RYO
<del>10196501</del>	Not Issued	030	07/15/2002	ELECTRONIC SETTLEMENT METHOD AND SYSTEM	SATOH, RYOJI
<del>10194131</del>	Not Issued	061	07/11/2002	TRANSACTION MANAGEMENT SYSTEM AND METHOD	SATOH, RYOJI
<del>10068939</del>	<del>6621217</del>	150	02/11/2002	WIRING SUBSTRATE AND GAS DISCHARGE DISPLAY DEVICE	SATOH, RYOHEI
<del>10061160</del>	<del>6624575</del>	150	02/04/2002	METHOD OF MAKING GAS DISCHARGE DISPLAY PANEL AND GAS DISCHARGE DISPLAY DEVICE	SATOH, RYOHEI
<del>09989063</del>	Not Issued	061	11/21/2001	RIB STRUCTURE FOR DISPLAY DEVICE AND ITS MANUFACTURE PROCESS	SATOH, RYOHEI
<del>09903495</del>	<del>6346772</del>	150	07/13/2001	WIRING SUBSTRATE AND GAS DISCHARGE DISPLAY DEVICE	SATOH, RYOHEI
<del>09851989</del>	<del>6343967</del>	150	05/10/2001	METHOD OF MAKING GAS DISCHARGE DISPLAY PANEL AND GAS DISCHARGE DISPLAY DEVICE	SATOH, RYOHEI
<del>09673920</del>	<del>6589453</del>	150	12/13/2000	A PROCESS PREPARING A TARGET FOR A THIN METAL OXIDE FILM	SATOH, RYO
<del>09299559</del>	<del>6652342</del>	150	04/27/1999	WIRING BOARD AND GAS DISCHARGE TYPE DISPLAY APPARATUS USING THE SAME	<del>SATOH, RYOHEI</del>

*parent*

<u>09264813</u>	<u>6137185</u>	150	03/09/1999	ELECTRONIC STRUCTURE OF WIRING SUBSTRATE OF SEMICONDUCTOR DEVICE HAVING EXPAND PITCH	SATOH , RYOHEI
<u>09232666</u>	<u>6333599</u>	150	01/19/1999	PLASMA DISPLAY SYSTEM	SATOH , RYOHEI
<u>09225552</u>	<u>6429586</u>	150	01/05/1999	GAS DISCHARGE DISPLAY PANEL AND GAS DISCHARGE DISPLAY DEVICE HAVING ELECTRODES FORMED BY LASER PROCESSING	SATOH , RYOHEI
<u>09120314</u>	<u>6102273</u>	150	07/22/1998	DIE BONDING APPARATUS	SATOH , RYOKO
<u>08955092</u>	<u>6199404</u>	150	10/21/1997	MANUFACTURING METHOD FOR GAS DISCHARGE TYPE DISPLAY PANEL	SATOH , RYOHEI
<u>08918019</u>	<u>5973406</u>	150	08/25/1997	ELECTRONIC DEVICE BONDING METHOD AND ELECTRONIC CIRCUIT APPARATUS	SATOH , RYOHEI
<u>08913131</u>	<u>5853315</u>	150	09/08/1997	SOUND GENERATING TOY	SATOH , RYOUICHI
<u>08893323</u>	<u>5939789</u>	150	07/16/1997	MULTILAYER SUBSTRATES METHODS FOR MANUFACTURING MULTILAYER SUBSTRATES AND ELECTRONIC DEVICES	SATOH , RYOHEI
<u>08781860</u>	<u>5886409</u>	150	01/10/1997	ELECTRODE STRUCTURE OF WIRING SUBSTRATE OF SEMICONDUCTOR DEVICE HAVING EXPANDED PITCH	SATOH , RYOHEI
<u>08761430</u>	<u>5865365</u>	150	12/06/1996	METHOD OF FABRICATING AN ELECTRONIC CIRCUIT DEVICE	SATOH , RYOHEI
<u>08753018</u>	<u>5878943</u>	150	11/19/1996	METHOD OF FABRICATING AN ELECTRONIC CIRCUIT DEVICE AND APPARATUS FOR PERFORMING THE METHOD	SATOH , RYOHEI
<u>08395466</u>	Not Issued	166	02/28/1995	A MULTILAYER WIRING INTERCONNECTION SUBSTRATE AND AN ELECTRONIC DEVICE INCORPORATING THE SAME	SATOH , RYOHEI
<u>08260382</u>	<u>5832595</u>	150	06/14/1994	METHOD OF MODIFYING CONDUCTIVE LINES OF AN	SATOH , RYOHEI

				ELECTRONIC CIRCUIT BOARD AND ITS APPARATUS	
<del>08240320</del>	<del>Not Issued</del>	<del>166</del>	<del>05/10/1994</del>	<del>METHOD OF FABRICATING ELECTRONIC CIRCUIT DEVICE AND APPARATUS FOR PERFORMING THE SAME METHOD</del>	<del>SATOH, RYOHEI</del>
08102783	5374793	250	08/06/1993	ACCELERATION SENSOR	SATOH, RYO
08102782	Not Issued	161	08/06/1993	ACCELERATION SENSOR	SATOH, RYO
07990617	5317029	150	12/14/1992	PHARMACEUTICAL COMPOSITION OF BENZOPYRANES FOR THE INHIBITION OF BONE RESORPTION	SATOH, RYOICHI
07988890	5294608	150	12/10/1992	GUANIDINOALKYL-1,1-BISPHOSPHONIC ACID DERIVATIVES, PROCESS FOR THEIR PREPARATION AND THEIR USE	SATOH, RYOICHI
07938517	5291419	150	01/06/1992	METHOD FOR DIAGNOSING THE LIFE OF A SOLDER CONNECTION	SATOH, RYOHEI
07890255	5341980	150	05/29/1992	METHOD OF FABRICATING ELECTRONIC CIRCUIT DEVICE AND APPARATUS FOR PERFORMING THE SAME METHOD	SATOH, RYOHEI
07820679	Not Issued	161	01/28/1992	AIR BAG UNIT	SATOH, RYO
07737712	5210384	150	07/30/1991	ACCELERATION SENSOR WITH MAGNETIC BIASED MASS AND ENCAPSULATED CONTACT TERMINALS AND RESISTOR	SATOH, RYO
07710985	5388031	250	06/06/1991	POWER SUPPLY UNIT AND WELDING EQUIPMENT	SATOH, RYODA
07676389	5151773	150	03/28/1991	ELECTRONIC CIRCUIT APPARATUS COMPRISING A STRUCTURE FOR SEALING AN ELECTRONIC CIRCUIT	SATOH, RYOHEI
07674599	5276289	150	03/25/1991	ELECTRONIC CIRCUIT DEVICE AND METHOD OF PRODUCING THE SAME	SATOH, RYOHEI

<u>07656465</u>	Not Issued	164	02/19/1991	METHOD OF FABRICATING ELECTRONIC CIRCUIT DEVICE	SATOH , RYOHEI
<u>07563281</u>	<u>5136360</u>	150	08/06/1990	ELECTRONIC CIRCUIT DEVICE, METHOD OF CONNECTING WITH SOLDER AND SOLDER FOR CONNECTING GOLD-PLATED TERMINALS	SATOH , RYOHEI
<u>07522531</u>	<u>5249100</u>	150	05/11/1990	ELECTRONIC CIRCUIT DEVICE PROVIDED WITH A CERAMIC SUBSTRATE HAVING LEAD PINS BONDED THERETO BY SOLDER	SATOH , RYOHEI
<u>07433911</u>	Not Issued	161	11/09/1989	ELECTRONIC CIRCUIT DEVICE AND THE PROCESS OF PRODUCING THE SAME	SATOH , RYOHEI
<u>07390616</u>	<u>5023407</u>	150	08/07/1989	PRINTED CIRCUIT BOARD WITH AN UNIFORM CONDUCTIVE LAYER FORMED BY EQUALIZATION OF METALS THEREIN	SATOH , RYOHEI
<u>07384296</u>	Not Issued	161	07/24/1989	SOLDER AND AN ELECTRONIC CIRCUIT USING THE SAME	SATOH , RYOHEI
<u>07097124</u>	<u>4908696</u>	250	09/16/1987	CONNECTOR AND SEMICONDUCTOR DEVICE PACKAGES EMPLOYING THE SAME	SATOH , RYOHEI
<u>06668843</u>	<u>4687939</u>	150	11/06/1984	METHOD AND APPARATUS FOR FORMING FILM BY ION BEAM	SATOH , RYOHEI
<u>06650886</u>	<u>4615430</u>	150	09/17/1984	PRECISION PALLET STACKING TYPE STORAGE SYSTEM FOR USE IN CLEAN ENVIRON MENT OR THE LIKE	SATOH , RYOZO
<u>06542989</u>	Not Issued	163	10/18/1983	SEMICONDUCTOR CHIP MOUNTED STRUCTURE AND METHOD OF MKAING THE SAME	SATOH , RYOHEI
<u>06322696</u>	Not Issued	161	11/18/1981	SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND MANUFACTURING METHOD OF SAME	SATOH , RYOHEI

<a href="#">06137023</a>	Not Issued	161	04/03/1980	REMOTE-CONTROLLED PRESSURE REGULATOR	SATOH, RYOZO
<a href="#">06132734</a>	<a href="#">4309961</a>	150	03/24/1980	APPARATUS FOR THERMAL TREATMENT OF SEMICONDUCTORS	SATOH, RYOZO
<a href="#">06132729</a>	<a href="#">4472622</a>	150	03/24/1980	APPARATUS FOR THERMAL TREATMENT OF SEMICONDUCTORS	SATOH, RYOZO

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<b>Search Another: Inventor</b>	<input type="text" value="satoh"/>	<input type="text" value="ryo"/>	<input type="button" value="Search"/>

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*Computer  
refused to  
search further*

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	IS&R	L1	7981	((219/121.6-121.62, 121.76-121.85) or (427/561, 568.585, 586, 596, 597)).CCL S.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 12:33
2	BRS	L2	175	1 and (PVD (pulsed adj (laser vapor)adj deposit\$4) or (laser adj ablation adj deposit\$4))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 12:36
3	BRS	L3	218	1 and (PVD (pulsed adj (laser vapor\$6)adj deposit\$4) or (laser adj (ablation evaporat\$4 vapor\$6) near3 deposit\$4))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 12:38
4	BRS	L4	224	1 and (PVD PLD (pulsed adj (laser vapor\$6)adj deposit\$4) or (laser adj (ablation evaporat\$4 vapor\$6) near3 deposit\$4))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:44
5	BRS	L5	1	4 and (metal adj chelate EDTA ethylenediaminete traacetic \$diaminetetraacet ic dihydroxyethylgly cerine (amino adj carboxylic aminocarboxylic) adj acid)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:46
6	BRS	L7	1	4 and (organic near3 (chelate complex))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:47

SN/10/C14, 290



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7	BRS	L6	24	4 and (metal near (organic carboxylic carboxylic acid) metalorganic metallorganic organometal\$4)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:47
8	BRS	L8	1922	1 and (physical adj <del>vapor\$6adj</del> deposit\$4) not 4	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:40
9	BRS	L9	9	8 and (metal adj chelate EDTA ethylenediamine tetraacetic \$diaminetetraacet ic dihydroxyethylgly cerine (amino adj carboxylic aminocarboxylic) adj acid)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
10	BRS	L10	19	8 and (organic near3 (chelate complex))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
11	BRS	L11	135	8 and (metal near (organic carboxylic carboxylic acid) metalorganic metallorganic organometal\$4)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
12	BRS	L12	35	8 and (metal near (organic carboxylic carboxylic acid) metalorganic metallorganic organometal\$4) sam e (target source)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:37
13	BRS	L13	138	10 or 11 or 12	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:38

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14	BRS	L14	59	10 or 9 or 12	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:38
15	BRS	L15	22	14 and target	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:39
16	BRS	L16	57	1 and ( physical adj vapor\$6 adj deposit\$4) not 4	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:40
17	BRS	L17	0	16 and (metal adj chelate EDTA ethylenediaminete traacetic \$diaminetetraacet ic dihydroxyethylgly cerine (amino adj carboxylic aminocarboxylic) adj acid)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
18	BRS	L18	4	16 and (organic near3 (chelate complex))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
19	BRS	L19	14	16 and (metal near(organic carboxylic carboxylicacid) metalorganic metallorganic organometal\$4)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:41
20	BRS	L20	14	18 or 19	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:42

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21	IS&R	L21	3156	(427/525,529,530,566,567,255.19,255.29-255.39).CCLS	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:43
22	BRS	L22	360	21 and (PVD PLD ((pulsed physical) adj (laser vapor\$6)adj deposit\$4) or (laser adj (ablation evaporat\$4 vapor\$6) near3 deposit\$4))not (5 or 6 or 7)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:45
23	BRS	L23	120	22 and target	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:46
24	BRS	L24	7	22 and (metal adj chelate EDTA ethylenediaminete traacetic \$diaminetetraacet ic dihydroxyethylgly cerine (amino adj carboxylic aminocarboxylic) adj acid)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:46
25	BRS	L25	6	22 and (organic near3 (chelate complex))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:47
26	BRS	L26	79	22 and (metal near (organic carboxylic carboxylicacid) metalorganic metallorganic organometal\$4)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:48

5

	Type	L #	Hits	Search Text	DBs	Time Stamp
27	BRS	L27	92	(20 or 24 or 25 or 26) not (5 or 6 or 7)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:49
28	BRS	L28	37	27 and target	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 13:49
29	BRS	L29	41	27 and (target source adj material)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:46
30	IS&R	L30	4138	((264/5,6,13,109, 115,123) or (505/425,446,445, 474,512)).CCLS.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:48
31	BRS	L31	86	30 and (PVD PLD ((pulsed physical) adj (laser vapor\$6)adj deposit\$4) or (laser adj (ablation evaporat\$4 vapor\$6) near3 deposit\$4))not (5 or 6 or 7)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:49
32	BRS	L32	2	31 and (metal adj chelate EDTA ethylenediaminete traacetic \$diaminetetraacet ic dihydroxyethylgly cerine (amino adj carboxylic aminocarboxylic) adj acid)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:49
33	BRS	L33	2	31 and (organic near3 (chelate complex))	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:49



	Type	L #	Hits	Search Text	DBs	Time Stamp
34	BRS	L34	18	31 and (metal near (organic carboxylic carboxylic acid) metalorganic metallorganic organometal\$4)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:50
35	BRS	L35	19	(32 or 33 or 34) not (29 or 5 or 6 or 7)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 14:51

	L #	Hits	Search Text	DBs	Time Stamp
1	L1	5	((("6465042") or ("6228502") or ("20040036059"))). PN.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/03/21 15:13

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10/614,290